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03500.015546.1



## **PATENT APPLICATION**

January 5, 2005

Date of Signature

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: TOSHIYASU SHIRASUNA ET AL.		) :	Examiner: Anna M. Crowell
Application No.: 10/729,005		; ;	Group Art Unit: 1763
Filed: December 8, 2003		:	
For:	PLASMA TREATMENT METHOD AND PLASMA TREATMENT APPARATUS	; ) ;	January 5, 2005
P.O.	missioner for Patents Box 1450 andria, VA 22313-1450		
	<u>AM</u>	ENDME	<u>ENT</u>
Sir:			
a)	Introductory Comments		
	In response to the Office A	ction of	October 5, 2004, kindly amend the
abov	e-identified application as follows:		
		Į t	hereby certify that this correspondence is being deposited with the Jnited States Postal Service as first-class mail in an envelope addressed o: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-450 on
		-	January 5, 2005 (Date of Deposit)  Peter Saxon
		-	(Name of Attorney for Applicant)